

*Add new claims 13-20 as shown below:*

Sub 13. (New) The method of claim 1 wherein the at least one mask feature includes at least one U-shaped mask feature.

14. (New) The method of claim 1 wherein the at least one mechanical alignment feature includes at least one rectangular tab.

15. (New) The method of claim 1 wherein the at least one mechanical alignment feature includes at least one rectangular slot.

A2 16. (New) The method of claim 9 wherein the ablating step comprises positioning a beam of the laser normal to the surface of the substrate having the conductive traces and mask features formed thereon.

17. (New) The method of claim 9 wherein the multiple mask features include multiple U-shaped mask features.

18. (New) The method of claim 9 wherein the plurality of mechanical alignment features includes multiple tabs.

19. (New) The method of claim 9 wherein the plurality of mechanical alignment features includes multiple rectangular tabs.

20. (New) The method of claim 9 wherein the plurality of mechanical alignment features includes multiple rectangular slots.